

Docket Number: 081468-0308636



PATENT APPLICATION

Client Reference: P-1519.010-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

ALBERT JAN HENDRIK KLOMP, et al.

Group Art Unit: 2851

Application No.: 10/797,725

Examiner: Kevin C. Gutierrez

Filed: March 11, 2004

Confirmation No.: 4128

For: LITHOGRAPHIC PROJECTION ASSEMBLY, LOAD LOCK AND METHOD FOR
TRANSFERRING OBJECTS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. One copy of each non-U.S. reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicant respectfully requests the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicant with the next Office communication to indicate that the references have been considered, per MPEP § 609.

This Information Disclosure Statement is being filed before the mailing date of a first Office Action after the filing of a request for continued examination under 37 C.F.R. §1.114. No certification or fee is required.

An English language version of the Taiwanese Official Action is attached for the Examiner's information.

Respectfully Submitted,
PILLSBURY WINTHROP SHAW PITTMAN LLP

Jean-Paul G. Hoffman
Registration Number 42668
Customer Number: 00909

Date: August 3, 2007
Telephone: (703) 770-7900
Facsimile: (703) 770-7901
P.O. Box 10500
McLean, VA 22102

FORM PTO-1449 (modified)
 To: U.S. Department of Commerce
 (PW FORM PAT-1449)
 Patent and Trademark Office



Atty. Dkt. No.	M#	Client Ref.
081468	0308636	P-1519.010-US
Applicant: KLOMP et al.		
Appln. No.: 10/797,725		
Filing Date: March 11, 2004		
Examiner: K. GUTIERREZ		Group Art Unit: 2851

**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Date: August 3, 2007

Page **1** of **1**

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
AR	2002/0052094 A1	05/2002	RYAN et al.	438	464	
BR						
CR						
DR						
ER						
FR						
GR						
HR						
IR						
JR						
KR						
LR						
MR						
NR						

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
					Enclosed	No	Enclosed	No
OR	JP 2003-068819	03/2003	JAPAN	KRAUS et al.		X		
PR	JP 2002-517055	06/2002	JAPAN	Not Available		X		X
QR	JP 2001-524267	11/2001	JAPAN	Not Available		X		X
RR	TW 315488	09/1997	TAIWAN	Not Available				
SR								
TR								
UR								
VR								

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

WR	Taiwanese Official Action issued for Taiwanese Patent Application No. 093106320, dated May 29, 2007.			X
XR				
YR				
ZR				
AA				
BB				

Examiner _____ Date Considered: _____

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.